

00684.003585

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: M. Seth
Takenobu KOBAYASHI et al.)	
	:	Group Art Unit: 2624
Application No.: 10/777,192)	
	:	Confirmation No.: 7532
Filed: February 13, 2004)	
	:	
For: SURFACE POSITION MEASURING METHOD)		February 26, 2009
AND APPARATUS	:	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated November 26, 2008, please amend the above-identified application as follows: